



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **MAIL STOP: RCE**  
Norio KIMURA et al. : Docket No. 2001-0660A  
Serial No. 09/864,208 : Group Art Unit 1763  
Filed May 25, 2001 : Examiner Sylvia MacArthur  
SUBSTRATE POLISHING APPARATUS AND: **Confirmation No. 1632**  
SUBSTRATE POLISHING METHOD

**PATENT OFFICE FEE TRANSMITTAL FORM**

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Request for Continued Examination (RCE) ..... \$770.00

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Respectfully submitted,

Norio KIMURA et al.

By

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